Outstanding Achievement Award | Outstanding Achievement Award | [Outstanding Achievement Award] Pioneering research and development of semiconductor dry etching technologies and the industrialization

[20a-KD-6~6][Outstanding Achievement Award] Pioneering research and development of semiconductor dry etching technologies and the industrialization

Masaharu Shiratani (Kyushu Univ.)

Sun. Mar 20, 2016 10:45 AM - 11:30 AM  KD (KD)

△ : Young Scientist Oral Presentation Award Applied

▲ : English Presentation

▼ : Both Award Applied and English Presentation

10:45 AM - 11:30 AM

[20a-KD-6][Outstanding Achievement Award] Pioneering research and development of semiconductor dry etching technologies and the industrialization

Ο Yasuhiro Horiike¹ (1.Univ. of Tsukuba)

Keywords: semiconductor dry etching technologies

Title: Pioneering research and development of semiconductor dry etching technologies and the industrialization